



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph Wasshuber, et al. Docket No: TI-31016
Serial No: 10/020,111 Conf. No: 5837
Examiner: Richard A. Booth Art Unit: 2812
Filed: 12/14/2001
For: METHODS AND APPARATUS FOR INDUCING STRESS IN A SEMICONDUCTOR DEVICE

AF/ksas
#8/Resp. ne
5/15/03
Sunder

AMENDMENT PURSUANT TO 37 CFR 1.116

Assistant Commissioner for Patents
Washington, DC 20231

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(a)
I hereby certify that the above correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on 5-6-03.

Ann Trent
Ann Trent

Dear Sir:

Responsive to the Office Action mailed March 6, 2003, in connection with the above identified application, Applicants respectfully submit the following remarks.

RECEIVED
MAY 12 2003
TECHNOLOGY CENTER 3000

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